IN THE UNITED STATES PATENT AND TRADEMARK OFFICE Application of **Applicants** Rhodes et. a Serial No. 09/008,53/ Filed 01/16/98 Title METHOD OF MAKING A SEMICONDUCTOR DEVICE HAVING IMPROVED CONTACTS TO A THIN CONDUCTIVE LAYER Docket No. MIO 0012 V2 **EATON** Examiner CERTIFICATE OF MAILING I hereby certify that this correspondence is being deposited with the Art Unit 2823 United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on Aug st 3, 2000 **Assistant Commissioner of Patents** Washington, DC 20231 RECLIVED Reg. No. 44,494 Sir: TECHNOLOGY CENTER 2800 RESPONSE This paper is being filed in response to the Office Action mailed July 5, 2000. Reconsideration of the present application is respectfully requested in light of the remarks and amendments below. IN THE CLAIMS 31. (Amended) A process for making a semiconductor device comprising: forming a [layer of conductive material] conductive layer having a topography that includes a substantially vertical component; forming a contact disposed adjacent to and contacting said vertical component; and forming a structure having an opening therein under said conductive layer and 용용 filling said opening with said conductive material to form said vertical component. 8,4 )8/09/2000 SSESHE1 00000039 09008\$31 (New) A process for making a semiconductor device comprising: forming a conductive layer having a thick region; and forming a contact thy hydically in contact with the thick region.